

LIST OF PRIOR ART CITED BY  
APPLICANT

(PTO-1449)

ATTY. DOCKET NO.  
**CIT/K-0019C**~~DIVISIONAL APPLN. OF~~  
APPLN. NO. **10/648,297**  
~~09/048,282~~APPLICANT(S)  
**Jong Geun YOON et al.**FILING DATE  
**August 27, 2003**GROUP  
~~unknown~~ **1774**

## U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
<i>MEY</i>	5,227,252	7/93	Murayama et al.	<i>428</i>	<i>690</i>	—
<i>MEY</i>	5,516,577	5/96	Matsuura et al.	<i>428</i>	<i>212</i>	—
<i>MEY</i>	5,593,788	1/97	Shi et al.	<i>428</i>	<i>690</i>	—
<i>MEY</i>	5,616,427	4/97	Tada	<i>428</i>	<i>690</i>	—
<i>MEY</i>	5,677,572	10/97	Hung et al.	<i>257</i>	<i>750</i>	—
<i>MEY</i>	6,137,223	10/00	Hung et al.	<i>313</i>	<i>506</i>	<i>07/1998</i>
<i>MEY</i>	6,172,459 B1	1/01	Hung et al.	<i>313</i>	<i>506</i>	<i>07/1998</i>
<i>MEY</i>	6,248,458 B1	6/01	Yoon et al.	<i>428</i>	<i>690</i>	—
<i>MEY</i>	5,281,489	1/94	Mori et al.	<i>428</i>	<i>690</i>	—
<i>MEY</i>	6,469,437 B1	10/02	Parthasarathy et al.	<i>313</i>	<i>504</i>	—

## U.S. PATENT APPLICATION PUBLICATIONS

*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS

## U.S. PATENT APPLICATIONS

*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)


EXAMINER

*Marie R. Yarnitzky*

DATE CONSIDERED

*May 10, 2005*

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.